

Electronic Patent Application Fee Transmittal

Application Number:	10813829			
Filing Date:	30-Mar-2004			
Title of Invention:	Method of plasma etch endpoint detection using a V-I probe diagnostics			
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Filer:	Joseph A. Nguyen/Cassandra Reynolds			
Attorney Docket Number:	P1258/LMRX-P037			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Petition-revive unintent. abandoned appl	1453	1	1540	1540
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				2350